



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION OF

Confirmation No.: 8174

Mitsuaki KOMINO *et al.*

Group Art Unit: 1763

Appln. No.: 09/667,770

Examiner: R. Zervigon

Filed: September 22, 2000

Title: PLASMA PROCESSING APPARATUS, AND ELECTRODE STRUCTURE AND  
TABLE STRUCTURE OF PROCESSING APPARATUS

November 21, 2003

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**AMENDMENT WITH A REQUEST FOR CONTINUED EXAMINATION**

Hon. Commissioner of Patents  
Washington, D.C. 20231

Sir:

In response to the Office Action dated May 29, 2003, please amend the above  
identified application as follows:

11/24/2003 EFLORES 00000100 033975 09667770

02 FC:1253 840.00 DA